NOV 14 2005

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	& TRADENARD	Application Number	10/646,467	1
	TRANSMITTAL	Filing Date	August 22, 2003	
FORM		First Named Inventor	Kenneth COLLINS, et al.	
		Art Unit	1763	_
(to be used for all correspondence after initial filing)		Examiner Name	Unknown	
	Total Number of Pages in This Submission 4	Attorney Docket Number	006915 P06	
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ENCLOSURES (Check all that apply)							
	Fee Transmittal Form	Drawing(s)		After Allowance Communication to TC			
	Fee Attached	Licensing-related Papers		Appeal Communication to Board of Appeals and Interferences			
Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s) Reply to Missing Parts/ Incomplete Application Reply to Missing Parts under 37 CFR 1.52 or 1.5		Petition Petition to Convert to a Provisional Application Power of Attorney, Revocati Change of Correspondence Terminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table on C Remarks	Address	Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (please Identify below):			
	SIGNA	TURE OF APPLICANT, ATTO	DRNEY, C	R AGENT			
Firm N	Law Office of	Robert M. Wallace					
Signature Rohley Muhaler							
Printe	Robert M. Wall						
Date	11/10/2005		Reg. No.	29,119			
CERTIFICATE OF TRANSMISSION/MAILING I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below:							
Signature Ally Aut							

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.11 and1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Shelly Hart

Typed or printed name

CERTIFICATE OF MAILING

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PATENT

Attorney Docket No. 6915 P06 RW Ref. No. APM/001-02-CP1-6

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Kenneth COLLINS, et al.))	Group	Art	Unit:	1763
Entitled: PLASMA IMMERSION I IMPLANTATION PROCESS USING A INDUCTIVELY COUPLED PLASMA S HAVING LOW DISSOCIATION AND MINIMUM PLASMA VOLTAGE	N) SOURCE)	Examir	ner:	Unknov	wn
Serial No.: 10/646,467	Ź				
Filing Date: August 22, 200	.)				

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached hereto is Form PTO-1449 listing documents believed relevant to the subject application. It is respectfully requested that these documents be made of record and an initialed copy of each form be returned to the undersigned.

No representation is made that more pertinent material is not available or should not be considered by the Examiner. It is expected that the Patent and Trademark Office will independently conduct a complete search of appropriate art. Furthermore, no admission is being made that these documents are prior art, and applicant reserves the right to challenge any such consideration.

It is believed that this disclosure complies with the requirements of 37 CFR 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures, section 609 and 707.05. If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each foreign patent document and/or non-patent literature is enclosed. Some of the documents may have markings on them. No significance is meant to be attached to the markings. These documents are not necessarily analogous art.

Respectfully submitted,

Dated: ///0/2013

Robert M. Wallace Registration No. 29,119 Customer No. 000044843 Attorney for Applicants

Robert M. Wallace Patent Attorney 2112 Eastman Avenue, Suite 102 Ventura, CA 93003 (805) 644-4035

INFORMATION NOV 14 2005 DISCLOSURE \3 STATEMENT B APPL Sheet 1 of 1

Application Number:

10/646,467

Filing Date:

August 22, 2003

First Named Inventor: Group Art Unit:

Kenneth COLLINS, et al. 1763

Examiner Name:

Unknown

Attorney Docket Number:

006915 P06

U. S. PATENT DOCUMENTS

Examiner Initials	Document No	Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date	
	US-6,395,150 B1	05-28-2002	CAN CLEEMPUT ET AL.	204	192.37	04-01-1998	
	US-6,413,321 B1	07-02-2002	KIM ET AL.	118	725	12-07-2000	
	US 2003/0013260 A1	01-16-2003	GOSSMAN ET AL.	438	301	07-16-2001	
	US 2003/0085205 A1	05-08-2003	LAI ET AL.	219	121.43	04-20-2001	
	1						

FOREIGN PATENT DOCUMENTS

Examiner Initials	Foreign Patent Document	Publication Date	Country	Name of Patentee or Applicant of Cited Document	Translation? (Yes/No/n/a)
	EP 1 158 071 A2	28.11.2001	EUROPE	APPLIED MATERIALS, INC.	N/A
	JP 070455542	14.02.1995	JAPAN	MATSUSHITA ELECTRIC IND CO LTD	N/A
	JP 2000150908	30.05.2000	JAPAN	SEMICONDUCTOR ENERGY LAB CO LTD	N/A
		<u> </u>	<u> </u>	L	<u> </u>

Examiner Initials

NON PATENT LITERATURE DOCUMENTS

Hu, C.-K., et al., "A process for improved Al(cu) reactive ion etching", Journal of Vacuum Science and Technology", May 1, 1989, pp. 682-685, Vol. 7, No. 3, American Institute of Physics, New York, U.S.

Examiner's Signature:

Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.